

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : Unassigned Confirmation No. Unassigned  
Applicant : Jurriaan Schmitz *et al.*  
Filed : Concurrently  
TC/A.U. : Unassigned  
Examiner : Unassigned

Docket No. : **BE02 0028US**  
Customer No. : 24738

Title : Method of Manufacturing a Semiconductor Device with a Silicon  
Body Provided with Field Isolation Regions Consisting of Grooves  
Filled with Isolating Material

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**PRELIMINARY AMENDMENT**

Sir:

Prior to calculation of the filing fee and examination please amend the above-identified application as follows:

**Amendments to the Specification** there are no amendments in this paper.

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.